



RCE/1762  
\$

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date August 11, 2003

In re the Application of

Shunichi SEKI et al.

Group Art Unit: 1762

Application No.: 09/701,534

Examiner: M. Cleveland

Filed: November 30, 2000

Docket No.: 107291

For: METHOD FOR FORMING SILICON FILM AND INK COMPOSITION FOR INK JET

**LARGE ENTITY PETITION FOR 1<sup>st</sup> - 3<sup>rd</sup> EXTENSION  
OF TIME UNDER 37 C.F.R. §1.136(a) AND  
TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a response to the outstanding Official Action in the above-identified patent application. The shortened statutory period having expired July 9, 2003, an extension of time for a period of one month is hereby requested. Attached hereto is our Check No. 145014 in the amount of \$110.00 in payment for:

<u>XX</u>	Extension fee for response within first month pursuant to §1.136(a) (\$110.00)
<u>      </u>	Extension fee for response within second month pursuant to §1.136(a) (\$410.00)
<u>      </u>	Extension fee for response within third month pursuant to §1.136(a) (\$930.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

James A. Oliff  
Registration No. 27,075

Jeffery M. Lillywhite  
Registration No. 53,220

08/13/2003 AWONDAF1 00000086 09701534

02 FC:1251

110.00 OP

JAO:JML/can

**OLIFF & BERRIDGE, PLC**  
P.O. Box 19928  
Alexandria, Virginia 22320  
Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
--